



PATENT

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September 9, 2003  
Date

  
Ayesha S. Wilks

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Dirk J. Sundt,  
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Attorney Docket No.: 501085.02

Serial No. : 10/620,782

Group Art Unit : Not Yet Assigned

Filed : July 15, 2003

Examiner : Not Yet Assigned

Title : STRUCTURE AND METHOD FOR FORMING A FACETED OPENING AND A  
LAYER FILLING THEREIN

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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449. This application relies, under 35 U.S.C. § 120, on the earlier filing date of prior Application No. 10/007,295, filed November 8, 2001. The references listed on the attached Form PTO-1449 were submitted to and/or cited by the Patent and Trademark Office in this prior application and, therefore, are not required to be provided in this application. If the Examiner wishes, copies will be provided upon request. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information

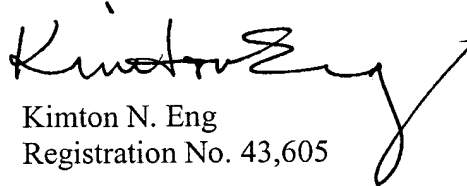
they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

I hereby certify that no item set forth on the attached form PTO-1449 was cited in a communication from a foreign patent office in a counterpart foreign application or, to my knowledge, after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of this Supplemental Information Disclosure Statement.

Please acknowledge receipt of this Supplemental Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,

DORSEY & WHITNEY LLP

  
Kimton N. Eng  
Registration No. 43,605

KNE:sem

Enclosures:

Postcard

Form PTO-1449

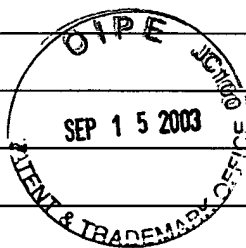
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FORM PTO-1449 (REV. 7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 10/620,782	APPLICATION NO. 501085.02
<b>INFORMATION DISCLOSURE STATEMENT</b> <i>(Use several sheets if necessary)</i>		APPLICANT(S) Dirk J. Sundt et al.	
		FILING DATE July 15, 2003	GROUP ART UNIT Not Yet Assigned

### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	6,177,331 B1	01/23/01	Koga	438	424	
	AB	6,548,371 B2	04/15/03	Fujimaki	438	424	
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						



### FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AK							
	AL							
	AM							
	AN							
	AO							

### OTHER PRIOR ART *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	AP	Cheung, N., Lecture notes (handout) EE 143, Lecture 15, University of California Berkely, 2000.
	AQ	Clark, S., "Chemical Etching of Silicon Nitride (Si <sub>3</sub> N <sub>4</sub> ) with Hot Phosphoric Acid (H <sub>3</sub> PO <sub>4</sub> )", Bold Technologies Technical Paper, 2000, pp. 1-6.
	AR	

EXAMINER	DATE CONSIDERED
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\* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).